



Applicant: Yamazaki, et al. Art Unit: 2871

Serial No.: 09/517,354 Examiner: Kenneth Parker

Filed : March 2, 2000

Title : METHOD OF MANUFACTURING A DISPLAY DEVICE HAVING A DRIVER

CIRCUIT ATTACHED TO A DISPLAY SUBSTRATE

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Applicant submits the references listed on the attached form PTO-1449.

Submitted herewith is an English translation of the following foreign language references, or portions thereof:

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Applicant: Yamazaki, et al. Serial No.: 09/517,354 Filed: March 2, 2000 Attorney's Docket No.: 07977-015003 / US2954/2957D1D1

Page : 2 of 2

This filing is being made with the filing of a Request for Continued Examination. No fees are believed to be due. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: 6/2/04

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Modified) PTO-1449 JUN 0 2 2007 By Applicant

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Attorney's Docket No. 07977-015003

Application No. 09/517,354

Applicant

Yamazaki, et al.

Filing Date March 2, 2000 Group Art Unit 2871

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| | ्राण्या र आप्रिकाmation Discl | osure Statement | Applicant Applicant | 09/517,354 |
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